



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Hua Ji  
Assignee: Mosel Vitelic, Inc.  
Title: HDP CVD Process For Void-Free Gap Fill Of A High Aspect Ratio Trench  
Serial No.: 10/080,468  
Examiner: Anh D. Mai  
Docket No.: M-12589US  
Filing Date: February 22, 2002  
Group Art Unit: 2814

Irvine, California  
September 29, 2003

Mail Stop Amendment  
COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Dear Sir:

In response to the Office Action dated May 27, 2003, Applicant submits the following amendments and remarks. A one-month extension of time, extending the period for response to September 29, 2003, is requested in an accompanying petition.

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